



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application Serial No. .... 09/651,422  
Filing Date .... August 30, 2000  
Inventor .... Jeffrey W. Honeycutt et al.  
Assignee .... Micron Technology Inc.  
Group Art Unit .... 2812  
Examiner .... Jennifer M. Kennedy  
Attorney's Docket No. .... MI22-1332  
Title: Methods of Forming Insulative Material Against Conductive Structures

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

To: Assistant Commissioner for Patents  
Washington, D.C. 20231

From: David G. Latwesen, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

Dear Sir:

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449 and copies of which are attached.

Citation of these references is respectfully requested.

A check in the amount of \$180.00 is enclosed to cover the fee specified under 37 C.F.R. § 1.17(p).

Respectfully submitted,

Dated:

4/12/02

By:

David G. Latwesen, Ph.D.  
Reg. No. 38,533

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